



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/625,166
Filing Date July 22, 2003
Inventor Janos Fucsko et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Stephen W. Smoot
Attorney's Docket No. MI22-2246
Customer No. 021567
Title Wet Etching Method of Removing Silicon From a Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first office action after the filing of a Request for Continued Examination. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 9-8-06

By: 
Mark S. Martin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2246		SERIAL NO.: 10/625,166	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Janos Fucsko et al.			
					FILING DATE July 22, 2003		GROUP ART UNIT: 2813	
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate
	AA	3,434,896	03/25/69	Chance				
	AB	5,099,304	03/24/92	Takemura et al.				
	AC	6,955,972 B2	10/18/05	Lee et al.				
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country		Class	Subclass	Translation
	AJ							Yes No
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>								